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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/712,936	11/14/2003	Sang Seok Lee	8733.940.00-US	9893
30827	7590 09/23/20	5	EXAMINER	
MCKENNA LONG & ALDRIDGE LLP 1900 K STREET, NW			KOCH, GEORGE R	
WASHINGTON, DC 20006			ART UNIT	PAPER NUMBER
	•		1734	

DATE MAILED: 09/23/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/712,936	LEE ET AL.				
Office Action Summary	Examiner	Art Unit				
	George R. Koch III	1734				
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the o	correspondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DOWN THE MAILING DOWN THE STATE OF THE MAILING DOWN THE STATE OF THE METERS OF	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tinuing will apply and will expire SIX (6) MONTHS from to, cause the application to become ABANDONE	N. mely filed the mailing date of this communication. ED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on <u>06 Ju</u>	<u>uly 2005</u> .					
2a) This action is FINAL . 2b) ⊠ This	This action is FINAL . 2b)⊠ This action is non-final.					
3) Since this application is in condition for alloward	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.				
Disposition of Claims						
4) Claim(s) 1-118 is/are pending in the application	☑ Claim(s) <u>1-118</u> is/are pending in the application.					
4a) Of the above claim(s) 8-10,48-51,107 and	4a) Of the above claim(s) 8-10,48-51,107 and 118 is/are withdrawn from consideration.					
5)⊠ Claim(s) <u>52-83 and 86-106</u> is/are allowed.						
6)⊠ Claim(s) <u>1-7,15-19,31,39-43 and 108-116</u> is/ar	☑ Claim(s) <u>1-7,15-19,31,39-43 and 108-116</u> is/are rejected.					
<u> </u>	☑ Claim(s) <u>11-14, 20-30, 32-38, 44-47, 115-117</u> is/are objected to.					
8) Claim(s) are subject to restriction and/o	r election requirement.					
Application Papers						
9) The specification is objected to by the Examine	er.					
10) The drawing(s) filed on is/are: a) acc	epted or b)☐ objected to by the	Examiner.				
Applicant may not request that any objection to the	drawing(s) be held in abeyance. Se	e 37 CFR 1.85(a).				
Replacement drawing sheet(s) including the correct		•				
11) The oath or declaration is objected to by the Ex	caminer. Note the attached Office	e Action or form PTO-152.				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of:						
1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No						
3. Copies of the certified copies of the prior	·	ed in this National Stage				
application from the International Bureau * See the attached detailed Office action for a list	, ,,,	ad				
dee the attached detailed Office action for a list	or the certified copies not receive	su.				
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) Interview Summary	(PTO-413)				
2) DNotice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail D					
 Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 	6) Other:	CION Application (1-10-102)				

DETAILED ACTION

Double Patenting

1. The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. See *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970);and, *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this application. See 37 CFR 1.130(b).

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Claims 1-7, 31 and 43 are provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1-118 of copending Application No. 10/661,472 in view of Satoshi (JP 2001-356353).

Although the conflicting claims are not identical, they are not patentably distinct from each other because Claim 1 of the instant invention is an obvious variation of claim 1 of the '472 application. Claim 1 appears to be fully encompassed by the limitations of claim 1 of the '472 application. The instant upper chamber unit, lower chamber unit, chamber moving means, upper stage, lower stage, first alignment means, and second alignment means match up respectively (the first and second alignment means cross read on the alignment camera and the alignment means of the '472 application).

However, the '472 application does not claim the sealing means.

In any event, Satoshi discloses a very similar apparatus (comprising a substrate bonding used in fabricating LCD devices, comprising a base frame (stand 2 and frame 3), an upper chamber unit (top chamber 21), a lower chamber unit (bottom chamber 10) mounted to the base frame, wherein the lower chamber unit is selectively connectable with the upper chamber unit (described in paragraph 0033), chamber moving means for raising and lowering the upper chamber unit (the movement is described in paragraphs 0015 and the means are items 29 and 30), an upper stage (item 28) mounted to the upper chamber unit, a lower stage (item 9) mounted to the lower chamber unit. Satoshi also discloses first alignment means for leveling the upper stage with respect to the lower stage (load cell 33, and shafts 59, and associated actuators - see Figures 1 and 2), and second alignment for horizontally aligning the upper stage with respect to the lower stage (image recognition camera - see paragraph 0037).). Satuoshi discloses the use of sealing means with this apparatus, and one in the art would appreciate that such sealing means would secure the internal environment and enable vacuum compression. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have utilized such sealing means in order to ensure a secure internal environment.

As to claim 2, Satoshi as incorporated discloses that the sealing means (O-ring 44) seals an interior space from an external environment, wherein the interior space is definable by connected ones of the upper and lower chamber units.

As to claim 3, Satoshi as incoropated discloses that the upper and lower stages are arrangeable within the interior space (see paragraph 0037) and that the sealing

means includes a central sealing member (O-ring 44), wherein the central sealing member defines the lateral boundary of the interior space.

As to claim 4 and 5, Satoshi as incorporated discloses that the central sealing member includes an elastic member (such as an O-ring) and that the first seal member includes an O-ring.

As to claim 6, Satoshi as incorporated discloses a first actuator (items 61 and 62), a first shaft (item 59) and a sensing means (load cell 33) as claimed.

As to claim 7, Satoshi as incorporated discloses load cells (item 33).

As to claim 31, Satoshi discloses that the chamber moving means includes a driving motor fixed to the base frame (item 40), a drive shaft (item 36) coupled to the drive motor, a connecting part connected to the driving shaft (item 37), a jack part (item 30) connected to the upper chamber unit and a connecting shaft (item 29) having one end connected to the upper chamber unit and the other end connected to receive a driving force from the driving shaft.

As to claim 43, Satoshi discloses at least one passage arranged with the upper stage and intersecting a lower surface of the upper stage (item 41, joint for attraction adsorption), and a suction force transmitter (item 42, attraction tube, and see paragraphs 0018-0021).

This is a <u>provisional</u> obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

2. Claims 15-19 are provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1-118 of copending Application No. 10/661,472 and Satoshi (the JPO database machine translation of JP 2001-356353) as applied to claim 1 above, and further in view of Miwa (US Patent 5,766,407)

As to claims 15 and 17, The '472 application and Satoshi discloses all of the limitations of claim 1, and also discloses that the upper chamber unit includes an upper side exposed to an external environment and an inner rim portion analogous to an upper chamber plate attached to the lower surface at a periphery (as in claim 15), nor discloses similar structures for the lower base and lower chamber plate (as in claim 17). However, Satoshi discloses one piece construction, and does not suggest the claimed two piece construction (i.e., upper base and upper chamber plates) for these elements.

Miwa, though, discloses that multiple component bonding chambers are known (see, for example, Figure 3). One in the art would appreciate that multiple component chambers allow for smaller replacement parts which would reduce the downtime for maintenance. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have used multiplece construction for chamber elements in order to enable smaller replacement parts, thus reducing maintenance downtime.

As to claim 16, Satoshi as modified by Miwa discloses that the upper chamber plate defines an upper space and that the upper stages is connected.

As to claim 18, Satoshi as incorporated discloses that the lower chamber plate is movable with respect to the lower base (via elements 4a, 4b, and 4c - see paragraphs 0012-0014).

As to claim 19, Satoshi as incorporated discloses that the lower chamber unit includes an lower side exposed to an external environment and an inner rim portion analogous to an lower chamber plate attached to the lower surface at a periphery. However, Satoshi discloses one piece construction, and does not suggest the claimed two piece construction for these elements.

Miwa, though, discloses that multiple component bonding chambers are known (see, for exaple, Figure 3). One in the art would appreciate that multiple component chambers allow for smaller replacement parts which would reduce the downtime for maintenance. Thererfore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have used multiplece construction for chamber elements in order to enable smaller replacement parts, thus reducing maintenance downtime.

3. Claims 39-42, and 108-114 are provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1-118 of copending Application No. 10/661,472 in view of Jin.

As to claim 39, the '472 application discloses all of the limitations of parent claim

1. However, '472 application is silent as to substrate loaders and correspondence
between the loader and the upper stage (i.e., grooves).

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Jin discloses the use of substrate loaders (item 112) and corresponding grooves (see item 111). One in the art would appreciate that grooves would facilitate quicker loading. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have included corresponding grooves in a bonding apparatus.

As to claim 40, the '472 application discloses that the upper stage includes vacuum holes and electrostatic chucks.

As to claims 41 and 42, Jin does not disclose that the grooves comprise the vacuum holes or the chucks.

As to claim 108, the '472 application in claim 1 discloses a substrate bonding apparatus with an upper stage and a lower stage (see Figure 1). However, '472 application is silent as to substrate loaders and correspondence between the loader and the upper stage (i.e., grooves).

Jin discloses the use of substrate loaders (item 112) and corresponding grooves (see item 111). One in the art would appreciate that grooves would facilitate quicker loading. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have included corresponding grooves in a bonding apparatus.

As to claim 109, the '472 application discloses that the upper stage includes vacuum holes and electrostatic chucks (see paragraph 0020, and 0026).

As to claims 110 and 111, Satoshi does not disclose that the grooves comprise the vacuum holes or the chucks.

As to claim 112, see claim 108 above. The '472 application also does not disclose a substrate loader. Jin discloses a substrate loader with fingers (item 112). One in the art would appreciate that such fingers would enable better substrate gripping capability. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have utilized such a finger in order to achieve better substrate gripping.

As to claim 113, the '472 application discloses a vacuum pipeline and on through hole.

As to claim 114, see claims 108, 112 and 113 above.

This is a <u>provisional</u> obviousness-type double patenting rejection.

Claim Rejections - 35 USC § 112

- 4. The following is a quotation of the second paragraph of 35 U.S.C. 112:
 - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 5. Claims 29-30 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 6. Claim 29 recites the limitation "second interval control groove" in line 2. Claim 29 also recites the limitation "the auxiliary sealing member" in line 3. There are insufficient

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antecedent basis for these limitations in the claim. There is no support in claims 18, 17, or 1 for a first interval control groove or an auxiliary sealing member. (note - it appears that the error is due to the fact that the claim might have been intended to be dependent of claim 28).

7. Claim 30 recites the limitation "the first interval control groove" in line 2. There is insufficient antecedent basis for this limitation in the claim. This is the first instance of "first interval control groove" in the dependency history (claims 29, 18, 17 or 1).

Claim Rejections - 35 USC § 102

8. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 9. Claims 1-7, 31, 43 are rejected under 35 U.S.C. 102(b) as being anticipated by Satoshi (machine translation of JP 2001-356353).

Satoshi discloses a substrate bonding used in fabricating LCD devices, comprising a base frame (stand 2 and frame 3), an upper chamber unit (top chamber 21), a lower chamber unit (bottom chamber 10) mounted to the base frame, wherein the lower chamber unit is selectively connectable with the upper chamber unit (described in paragraph 0033), chamber moving means for raising and lowering the upper chamber unit (the movement is described in paragraphs 0015 and the means are items 29 and 30), an upper stage (item 28) mounted to the upper chamber unit, a lower stage (item 9)

mounted to the lower chamber unit. Satoshi also discloses first alignment means for leveling the upper stage with respect to the lower stage (load cell 33, and shafts 59, and associated actuators - see Figures 1 and 2), and second alignment for horizontally aligning the upper stage with respect to the lower stage (image recognition camera - see paragraph 0037).

As to claim 2, Satoshi discloses that the sealing means (O-ring 44) seals an interior space from an external environment, wherein the interior space is definable by connected ones of the upper and lower chamber units.

As to claim 3, Satoshi discloses that the upper and lower stages are arrangeable within the interior space (see paragraph 0037) and that the sealing means includes a central sealing member (O-ring 44), wherein the central sealing member defines the lateral boundary of the interior space.

As to claim 4 and 5, Satoshi discloses that the central sealing member includes an elastic member (such as an O-ring) and that the first seal member includes an O-ring.

As to claim 6, Satoshi discloses a first actuator (items 61 and 62), a first shaft (item 59) and a sensing means (load cell 33) as claimed.

As to claim 7, Satoshi discloses load cells (item 33).

As to claim 31, Satoshi discloses that the chamber moving means includes a driving motor fixed to the base frame (item 40), a drive shaft (item 36) coupled to the drive motor, a connecting part connected to the driving shaft (item 37), a jack part (item 30) connected to the upper chamber unit and a connecting shaft (item 29) having one

end connected to the upper chamber unit and the other end connected to receive a driving force from the driving shaft.

As to claim 43, Satoshi discloses at least one passage arranged with the upper stage and intersecting a lower surface of the upper stage (item 41, joint for attraction adsorption), and a suction force transmitter (item 42, attraction tube, and see paragraphs 0018-0021).

Claim Rejections - 35 USC § 103

- 10. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 11. The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:
 - 1. Determining the scope and contents of the prior art.
 - 2. Ascertaining the differences between the prior art and the claims at issue.
 - 3. Resolving the level of ordinary skill in the pertinent art.
 - 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

12. Claims 15-19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Satoshi (the JPO database machine translation of JP 2001-356353) as applied to claim 1 above, and further in view of Miwa (US Patent 5,766,407)

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As to claims 15 and 17, Satoshi discloses all of the limitations of claim 1, and also discloses that the upper chamber unit includes an upper side exposed to an external environment and an inner rim portion analogous to an upper chamber plate attached to the lower surface at a periphery (as in claim 15), nor discloses similar structures for the lower base and lower chamber plate (as in claim 17). However, Satoshi discloses one piece construction, and does not suggest the claimed two piece construction (i.e., upper base and upper chamber plates) for these elements.

Miwa, though, discloses that multiple component bonding chambers are known (see, for example, Figure 3). One in the art would appreciate that multiple component chambers allow for smaller replacement parts which would reduce the downtime for maintenance. Thererfore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have used multiplece construction for chamber elements in order to enable smaller replacement parts, thus reducing maintenance downtime.

As to claim 16, Satoshi as modified by Miwa discloses that the upper chamber plate defines an upper space and that the upper stages is connected.

As to claim 18, Satoshi discloses that the lower chamber plate is movable with respect to the lower base (via elements 4a, 4b, and 4c - see paragraphs 0012-0014).

As to claim 19, Satoshi discloses that the lower chamber unit includes an lower side exposed to an external environment and an inner rim portion analogous to an lower

chamber plate attached to the lower surface at a periphery. However, Satoshi discloses one piece construction, and does not suggest the claimed two piece construction for these elements.

Miwa, though, discloses that multiple component bonding chambers are known (see, for exaple, Figure 3). One in the art would appreciate that multiple component chambers allow for smaller replacement parts which would reduce the downtime for maintenance. Thererfore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have used multiplece construction for chamber elements in order to enable smaller replacement parts, thus reducing maintenance downtime.

13. Claims 39-42, 108-114 are rejected under 35 U.S.C. 103(a) as being unpatentable over Satoshi (machine translation of JP 2001-356353) in view of Jin (US Patent 5,979,739).

As to claim 39, Satoshi discloses all of the limitations of parent claim 1.

However, Satoshi is silent as to substrate loaders and correspondence between the loader and the upper stage (i.e., grooves).

Jin discloses the use of substrate loaders (item 112) and corresponding grooves (see item 111). One in the art would appreciate that grooves would facilitate quicker loading. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have included corresponding grooves in a bonding apparatus.

As to claim 40, Satoshi discloses that the upper stage includes vacuum holes and electrostatic chucks (see paragraph 0020, and 0026).

As to claims 41 and 42, Satoshi does not disclose that the grooves comprise the vacuum holes or the chucks.

As to claim 108, Satoshi discloses a substrate bonding apparatus with an upper stage and a lower stage (see Figure 1). However, Satoshi is silent as to substrate loaders and correspondence between the loader and the upper stage (i.e., grooves).

Jin discloses the use of substrate loaders (item 112) and corresponding grooves (see item 111). One in the art would appreciate that grooves would facilitate quicker loading. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have included corresponding grooves in a bonding apparatus.

As to claim 109, Satoshi discloses that the upper stage includes vacuum holes and electrostatic chucks (see paragraph 0020, and 0026).

As to claims 110 and 111, Satoshi does not disclose that the grooves comprise the vacuum holes or the chucks.

As to claim 112, see claim 108 above. Satoshi also does not disclose a substrate loader. Jin discloses a substrate loader with fingers (item 112). One in the art would appreciate that such fingers would enable better substrate gripping capability. Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to have utilized such a finger in order to achieve better substrate gripping.

As to claim 113, Satoshi discloses a vacuum pipeline and on through hole (items 41 and 42 - see paragraph 0020).

As to claim 114, see claims 108, 112 and 113 above.

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Allowable Subject Matter

- 14. Claims 44-47, 115-117 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 15. The following is a statement of reasons for the indication of allowable subject matter: the prior art of record does make obvious a vacuum pump, and discloses a pipeline and through hole, but does not disclose that the suction force transmitter includes a driving part for moving the pipeline within the passage..
- 16. Claims 22-30 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 17. The following is a statement of reasons for the indication of allowable subject matter: The prior art of record does not suggest interval control grooves in the apparatus of claim 1.
- 18. Claims 32-38 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

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19. The following is a statement of reasons for the indication of allowable subject matter: The prior art of record does not suggest interval control means in the apparatus of claim 1.

- 20. Claims 11-14 and 20-21 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 21. Claims 52-83 are allowed.
- 22. The following is an examiner's statement of reasons for allowance: The prior art of record does discloses most of the limitations of claim 52 (see rejection of claim 1 above over Satoshi), but does not disclose or suggest interval control grooves in the apparatus.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

- 23. Claims 86-106 are allowed.
- 24. The following is an examiner's statement of reasons for allowance: The prior art of record does discloses most of the limitations of claim 86 (see rejection of claim 1 above over Satoshi), but does not disclose or suggest interval control means in the apparatus.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Response to Arguments

- 25. Applicant's arguments with respect to the obvious double patenting rejections are persuasive and the rejection has been expanded in order to include the analysis.
- 26. Applicant's arguments with respect to the rejections under Satoshi have been fully considered but they are not persuasive. Satoshi does disclose alignment means as set forth above.
- 27. Applicant's arguments as to claims 11-14 and 20 are persuasive.
- 28. In response to applicant's argument that there is no suggestion to combine the references, specifically Jin with either Satoshi or Lee (ODP rejection), the examiner recognizes that obviousness can only be established by combining or modifying the teachings of the prior art to produce the claimed invention where there is some teaching, suggestion, or motivation to do so found either in the references themselves or in the knowledge generally available to one of ordinary skill in the art. See *In re Fine*, 837 F.2d 1071, 5 USPQ2d 1596 (Fed. Cir. 1988) and *In re Jones*, 958 F.2d 347, 21 USPQ2d 1941 (Fed. Cir. 1992). In this case, one of ordinary skill in the art would appreciate that the grippers of Jim and loaders of Jin would provide better control over the substrate.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to George R. Koch III whose telephone number is (571) 272-1230 (TDD only). If the applicant cannot make a direct TDD-to-TDD call, the applicant can communicate by calling the Federal Relay Service at 1-866-377-8642 and giving the operator the above TDD number. The examiner can normally be reached on M-Th 10-7.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Christopher Fiorilla can be reached on (571) 272-1187. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

George R. Koch III Patent Examiner Art Unit 1734

GRK 9/20/2005